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Applicant: Charles M. McKenna et al.
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Confirmation No: 9493
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For: ION IMPLANTER HAVING TWO-STAGE DECELERATION
BEAMLINE
Examiner: Mary A. El-Shammaa
Art Unit: 2881

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

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Sir:

RESPONSE AFTER FINAL

In response to the Final Office Action mailed August 1, 2003, the following remarks are provided in connection with the above-identified application as follows.

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